





APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO	
10/052,853	11/09/2001	Glen Wada	042390P7196D	4202	
75	90 11/25/2002				
Michael A. Bernadicou BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP Seventh Floor 12400 Wilshire Boulevard			EXAMINER		
			CHEN, JACK S J		
Los Angeles, CA 90025-1026			ART UNIT	PAPER NUMBER	
			2813	\boldsymbol{C}	
			DATE MAILED: 11/25/2002	9	

Please find below and/or attached an Office communication concerning this application or proceeding.

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Application No. 10/052,853 Applicant(s)

Wada et al.

Office Action Summary

Examiner

Jack Chen

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	The MAILING DATE of this communication appears or	n the cover she	et with t	the correspondence address		
Period f	or Reply	0 57055	2	NAONTHYS) FROM		
THE N	DRTENED STATUTORY PERIOD FOR REPLY IS SET T MAILING DATE OF THIS COMMUNICATION. ons of time may be available under the provisions of 37 CFR 1.136 (a). In no date of this communication.	event, however, ma	ry a reply b	e timely filed after SIX (6) MONTHS from the		
- If the p - If NO p - Failure - Any rep	eriod for reply specified above is less than thirty (30) days, a reply within the eriod for reply is specified above, the maximum statutory period will apply and to reply within the set or extended period for reply will, by statute, cause the ply received by the Office later than three months after the mailing date of this patent term adjustment. See 37 CFR 1.704(b).	l will expire SIX (6) h application to becom	AONTHS fr BANDO	om the mailing date of this communication. NED (35 U.S.C. § 133).		
Status						
1) X	Responsive to communication(s) filed on <u>Sep 12, 20</u>			· .		
2a) 💢	This action is FINAL . 2b) ☐ This action	on is non-final.				
3) 🗆	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11; 453 O.G. 213.					
Disposit	tion of Claims					
4) 💢	Claim(s) 9-15			is/are pending in the application.		
4	a) Of the above, claim(s)			is/are withdrawn from consideration.		
5) 🗆	Claim(s)					
6) 💢						
7) 🗆	Claim(s)					
8) 🗍	Claims					
	ition Papers					
	The specification is objected to by the Examiner.					
10)💢	The drawing(s) filed on Nov 9, 2001 is/are	a) 🗌 accepte	d or b)	🕱 objected to by the Examiner.		
-,,,	Applicant may not request that any objection to the dr					
11)	The proposed drawing correction filed on	is:	a) 🗆 a	approved b) \square disapproved by the Examiner.		
	If approved, corrected drawings are required in reply to					
12)	The oath or declaration is objected to by the Examir	ner.				
	under 35 U.S.C. §§ 119 and 120					
13)□	Acknowledgement is made of a claim for foreign pri	iority under 35	U.S.C.	§ 119(a)-(d) or (f).		
a)[☐ All b) ☐ Some* c) ☐ None of:					
	1. \square Certified copies of the priority documents have					
	2. \square Certified copies of the priority documents have					
	3. Copies of the certified copies of the priority do application from the International Bures	au (PCT Rule 1	7.2(a)).			
*5	See the attached detailed Office action for a list of the					
14)∐	_					
	The translation of the foreign language provisiona Acknowledgement is made of a claim for domestic					
15) X		priority under	55 5.5			
Attachr	nent(s) lotice of References Cited (PTO-892)	4) Interview Su	ımmary (PT	O-413) Paper No(s)		
2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 5) Notice of Informal Patent Application (PTO-152)						
	3) Information Disclosure Statement(s) (PTO-1449) Paper No(s) 6) Cther:					

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DETAILED ACTION

In response to the communications dated September 12, 2002, claims 9-15 are active in 1. this application.

Drawings

The drawings are objected to under 37 CFR 1.83(a). The drawings must show every 2. feature of the invention specified in the claims. Therefore, the passivation layer covering the flash memory cell must be shown or the feature(s) canceled from the claim(s). No new matter should be entered.

A proposed drawing correction or corrected drawings are required in reply to the Office action to avoid abandonment of the application. The objection to the drawings will not be held in abeyance.

Claim Rejections - 35 USC § 112

The following is a quotation of the first paragraph of 35 U.S.C. 112: 3.

The specification shall contain a written description of the invention, and of the manner and process of making and using it, in such full, clear, concise, and exact terms as to enable any person skilled in the art to which it pertains, or with which it is most nearly connected, to make and use the same and shall set forth the best mode contemplated by the inventor of carrying out his invention.

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4. Claims 9-15 are rejected under 35 U.S.C. 112, first paragraph, as containing subject matter which was not described in the specification in such a way as to enable one skilled in the art to which it pertains, or with which it is most nearly connected, to make and/or use the invention. Re claim 9, the phrase "the passivation layer covering the flash memory cell" is not supported by the original disclosure.

Claim Rejections - 35 USC § 102

5. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 6. Claims 9-11, 15 are rejected under 35 U.S.C. 102(b) as being anticipated by Kiyohiko [JPO Publication Number: 04-078,173].

Kiyohiko discloses a flash memory (called "EPROM" in Kiyohiko, English abstract section, lines 1-4) comprising: a semiconductor substrate 1 (fig. 1) that includes a flash memory cell (called "EPROM element" in Kiyohiko, English abstract section, lines 1-4) that has a floating gate 3 (fig. 1, English abstract section, lines 10); a conductive layer 7 (fig. 1, called "aluminum wiring" in Kiyohiko, English abstract section, line 8) formed on the substrate 1; and a passivation layer 9 and 10 (fig. 1, English abstract section, lines 5-6) formed on the conductive layer 7 that is not transparent to ultraviolet light (called "opaque to ultraviolet rays" in Kiyohiko, English

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abstract section, line 9), the passivation layer covering the flash memory cell (fig. 1, abstraction section, lines 11-13; note: the passivation layer 9 by itself is covering the flash memory cell, and the passivation layer 10 by itself is also at least covering a least a portion of the flash memory cell).

Regarding claim 10, wherein the passivation layer comprises a barrier layer 9 (fig. 1, called "silicon nitride film" in Kiyohiko, English abstract section, line 5, which is the same material as applicant's disclosure, see page 5, line 4 of the instant application) and a stress reduction layer 10 (fig. 1, called "polyimide film" in Kiyohiko, English abstract section, lines 5-6 and 2-4, which is the same material as applicant's disclosure, see page 5, lines 4-5 of the instant application).

Regarding claim 11, wherein the passivation layer comprises a silicon nitride layer 9 (fig. 1, called "silicon nitride film" in Kiyohiko, English abstract section, line 5) and a polyimide layer 10 (fig. 1, called "polyimide film" in Kiyohiko, English abstract section, lines 5-6 and 2-4).

Regarding claim 15, wherein the passivation layer comprises a polyimide layer 10 (fig. 1, called "polyimide film" in Kiyohiko, English abstract section, lines 5-6 and 2-4).

Claim Rejections - 35 USC § 103

- 7. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person

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having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103© and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

8. Claims 12-14 are rejected under 35 U.S.C. 103(a) as being unpatentable over Kiyohiko [JPO Publication Number: 04-078,173] in view of Jeuch [U.S. Patent Number: 5,138,573].

Kiyohiko disclosed above in paragraph 6, in particular, the device comprises a floating gate 3 having the physical gate length as shown in fig. 1; however, Kiyohiko is silent to the floating gate having a length that is less than about 0.5 microns.

Jeuch teaches a EPROM (col. 1, lines 5-10) comprising a floating gate (col. 2, lines 49-53) having a length (called "width" in Jeuch, col. 2, lines 49-50) that is less than 0.5 microns (col. 2, lines 49-53 and col. 3, lines 44-50), which greatly contributes to reducing the dimensions of the storage cell (col. 2, lines 49-53).

Regarding claim 13, Kiyohiko shows the conductive layer forms the final metal interconnect 7 (fig. 1, called "aluminum wiring" in Kiyohiko, English abstract section, line 8) for

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the flash memory (called "EPROM" in Kiyohiko, English abstract section, lines 1-4), upon which is formed the passivation layer 9 and 10 (fig. 1).

Regarding claim 14, Kiyohiko shows the silicon nitride layer 9 (fig. 1) is about 0.3 μ m (page 466, left column, lines 1-3, which corresponds to 3000 angstroms) thick.

Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the device structure of Kiyohiko to select the suitable floating gate length as taught by Jeuch in order to reduce the dimensions of the storage cell (col. 2, lines 49-53), such will reduce the dimensions of the integrated circuits and increase the integration density (col. 1, lines 27-30). Further in this regard, it has been held that discovering an optimum value of a result effective variable involves only routine skill in the art. *In re Boesch*, 617 F.2d 272, 205 USPQ 215 (CCPA 1980).

Response to Arguments

9. Applicant's arguments filed September 12, 2002 have been fully considered but they are not persuasive.

Applicant stated that the support for the new added limitation (Re claim 9, the phrase "the passivation layer covering the flash memory cell") in claim 9 can be found at page 6, line 3 through page 7, line 2. The Examiner disagrees because page 6, line 3 through page 7, line 2 does not show this particular limitation.



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Applicant argued that EPROM and flash memories are different types of memory device. The Examiner disagrees because EPROM is a type of flash memories (flash memories, such as EPROM is non-volatile memory device). Further in this regard, applicant also stated that EPROM is an example of flash memory devices in the specification, page 2, lines 12-16. Furthermore, Kiyohiko teaches a *semiconductor device*, such as *memory transistor* (*EPROM* element).

Applicant further stated that the prior art (Jeuch, U.S./5,138,573) distinguishes EPROMs from flash memories at column 1, lines 6-11. The Examiner disagrees because Jeuch states "More specifically, the invention relates to *EPROM* (Erasable Programmable Read Only Memory) and *EEPROM* (Electrically Erasable Programmable Read Only Memory) cells of *the flash type*" (which EPROM is a type of flash memory, also see col. 2, lines 4-7).

Applicant stated that the prior art (Kiyohiko) must include the window 11. The Examiner disagrees because the abstract section (lines 11-13), clearly states "It is not necessary to provide the window 11 to each EPROM element".

Conclusion

10. THIS ACTION IS MADE FINAL. Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO

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MONTHS of the mailing date of this final action and the advisory action is not mailed until after

the end of the THREE-MONTH shortened statutory period, then the shortened statutory period

will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR

1.136(a) will be calculated from the mailing date of the advisory action. In no event, however,

will the statutory period for reply expire later than SIX MONTHS from the mailing date of this

final action.

11. Any inquiry concerning this communication or earlier communications from the examiner

should be directed to Jack Chen whose telephone number is (703) 308-5838. The examiner can

normally be reached on Monday-Friday (alternate Monday off) from 8:30 am to 6:00 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Carl Whitehead, Jr., can be reached on (703)308-4940. The fax phone numbers for

the organization where this application or proceeding is assigned are 703-872-9318 for regular

communications and 703-872-9319 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding

should be directed to the receptionist whose telephone number is (703)308-0956.

Jack Chen

JACK CHEN

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November 22, 2002

CARL WHITEHEAD, JR. UPERVISORY PATENT EXAMINER

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